PTO/SB/08A (08-00) Approved for use through 10/31/2002. OMB 0651-0031 U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Substitute for form 1449A/PTO Complete if Known Application Number INFORMATION DISCLOSURE 10/026,462 Filing Date STATEMENT BY APPLICANT December 27, 2002 First Named Inventor Takeuchi et al. Group Art Unit 1731 (use as many sheets as necessary) Examiner Name TBA Sean Vincent Sheet of Attorney Docket Number KOJIM-444 U.S. PATENT DOCUMENTS U.S. Patent Document Examiner Initials * Name of Patentee or Applicant of Cited Document Date of Publication of Cited Document Kind Code Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear (if known) MM-DD-YYYY A1 4,274,907 Α Vig et al. 06/23/81 A2 H532 Brandmayr 10/04/88 FOREIGN PATENT DOCUMENTS Foreign Patent Document Examined Name of Patentee Date of Publication of iges, Columns, Lines, or Applicant of Where Relevant Kind Code Cited Document Number⁴ Cited Document Passages or Relevant MM-DD-YYYY B1 Figures Appear Τs JP 11335140 А Naoki 12/07/99 **B2** JP 2000302482 Yasuhiro 10/31/00 OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of Cite the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue Examiner Initials No. number(s), publisher, city and/or country where published T² Takeuchl et al. "Properties of our developing next generation photomask substrate" Database accession No. 6584331, abstract. Photomask and X-Ray Mask technology VI, Yokohama, Japan, 13-14, April 1999, Vol. 3748, pp. 41-52 Patent Abstracts of Japan, Vol. 2000, No. 03, March 30, 2000, abstract Patent Abstracts of Japan, Vol. 2000, No. 13, 02/05/01, abstract Phase Shift Mask Fabrication Using Reactive Ion Etching of Quartz Substrates" Research Disclosure, Kenneth Mason Publications, Hampshire, GB, No. 340, August 1, 1992, page 682, abstract Examiner Signature Date Considered EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not conformance and not considered. Include copy of this form with next communication to applicant.

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